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10/811.979

March 30, 2004

KAMIYAMA et al.

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Substitute for form 1449A/B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

1

of

1

U.S. PATENT DOCUMENTS

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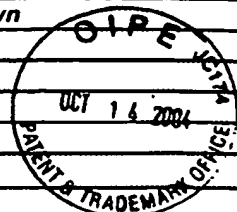
Examiner Signature

Date Considered

- * A concise statement of relevance is being submitted in lieu of a translation. 37 CFR 1.98(a)(3).
- * An English-language equivalent patent, or an English-language abstract, or an English-language version of the search report or action by a foreign patent office in a counterpart foreign application indicating the degree of relevance found by the foreign office is being submitted in lieu of a concise explanation of relevance under 37 CFR 1.98(a)(3).

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
Sheet		1	of	1	Application Number 10/811,979
					Filing Date March 30, 2004
					First Named Inventor KAMIYAMA
					Group Art Unit 2811
					Examiner Name Unassigned
					Attorney Docket Number 403018



U.S. PATENT DOCUMENTS						
Examiner Initials	Doc. No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication	Filing Date If Appropriate
		Application or Patent Number	Kind Code			
LP	B 1	2003/0218223		Nishiyama et al.	11/27/03	

FOREIGN PATENT DOCUMENTS								
Examiner Initials	Doc. No.	Foreign Patent Document			Name of Patentee or Applicant	Date of Publication	Translation	
		Office	Application or Patent Number	Kind Code			Yes	No**
LP	B 2	EP	1 363 333		Matsushita Elec. Ind. Co. , Ltd.	11/19/03		

OTHER - NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Doc. No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number (s), publisher, city and/or country where published.	Translation		
			Yes	No**	
LP	B 3	VAINONEN-AHLGREN, E. et al.; "Atomic layer deposition of hafnium and zirconium silicate thin films", <i>Computational Materials Science</i> , Vol. 27, No. 1-2, pp. 65-69, (March 2003).			
LP	B 4	HU, H. et al.; "MIM Capacitors Using Atomic-Layer-Deposited High-K (HfO ₂) _{1-x} (Al ₂ O ₃) _x Dielectrics", <i>IEEE Electron Device Letters</i> , Vol. 24, No. 2, pp. 60-62, (Feb. 2003).			

Examiner Signature	Long Pham	Date Considered	8/3/05
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